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Examiner | Ref.

Title

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 509982000600

Application Number 09/727,530

Applicant

Nickhil JAKATDAR, et al.

Filing Date November 28, 2000

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U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
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FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
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OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Initials	No.	
HP	1.	Xinhui Niu, "AN INTEGRATED SYSTEM OF OPTICAL METROLOGY FOR DEEP SUB-MICRON LITHOGRAPHY", Electronics Research Lab., College of Engineering UC Berkeley, 4/1999, 139 pgs.
HP	2.	William H. Press et al., "NUMERICAL RECIPES in C", The Art of Scientific Computing, Sec. Ed., pp. 444-455, Cambridge University Press, 1986.

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